



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

## BIB DATA SHEET

CONFIRMATION NO. 2848

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.	
10/542,358	07/14/2005	420	1793	273117US0PCT	
<b>RULE</b>					
<b>APPLICANTS</b> Yasuaki Yokoyama, Tokyo, JAPAN, Deceased; Michiko Yokoyama, Mie, JAPAN, Legal Representative; Naomi Shinoda, Aichi, JAPAN, Legal Representative; Risa Yokoyama, Mie, JAPAN, Legal Representative; Yasuo Matsuki, Chuo-ku, Tokyo, JAPAN;					
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/16579 12/24/2003					
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-8933 01/17/2003					
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 08/08/2006					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /MARK L SHEVIN/ Acknowledged /Examiner's signature	<input type="checkbox"/> Met after Allowance /MLS/ Initials	<b>STATE OR COUNTRY</b>  JAPAN	<b>SHEETS DRAWINGS</b>  1	<b>TOTAL CLAIMS</b>  5	<b>INDEPENDENT CLAIMS</b>  1
<b>ADDRESS</b> OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES					
<b>TITLE</b> Composition for forming silicon-aluminum film, silicon-aluminum film and method for forming the same					
<b>FILING FEE RECEIVED</b> 1260	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		